Ref <sup>t</sup>	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
Li	65	tamura-naoyuki.in.	US-PGPUB; USPAT	OR	ON	2005/04/16 20:08
S1	0	(sens\$3 with compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor)) and (118/715-733.ccls. 156/345.\$.ccls. 414/935-941.ccls.)	US-PGPUB; USPAT	OR	ON	2004/08/08 17:30
S2	3	(compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor):) and (118/715-733.ccls.:156/345:\$, ccls.:414/935-941.ccls.:)	US-PGPUB; USPAT	OR	ON	2004/08/08:17:33
S3	206	(compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor) )	US-PGPUB; USPAT	OR	ON	2004/08/08 17:31
S4	4	(compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor)) same (transfer\$4 convey\$4 transport\$4)	US-PGPUB; USPAT	OR	ON	2004/08/08 17:33
S5	206	(compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor) )	US-PGPUB; USPAT	OR .	ON	2004/08/08 17:35
S6	3	(compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor)) same (transfer\$4 convey\$4 transport\$4)	EPO; JPO; DERWENT	OR	ON	2004/08/08 17:33
<b>S</b> 7	99	((sens\$3 detect\$3 measur\$3) with compar\$3 with line with position\$4 with (wafer substrate workpiece semiconductor) )	US-PGPUB; USPAT	OR .	ON	2004/08/08 17:36
S8	105	((sens\$3 detect\$3 measur\$3) with compar\$3 with line with (align\$4 position\$4) with (wafer substrate workpiece semiconductor))	US-PGPUB; USPAT	OR	ON	2004/08/08 17:39
S9	321	(414/936).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/08/08 17:39
S10	244	S9 and (sens\$3 detect\$3)	US-PGPUB; USPAT	OR	ON	2004/08/08 17:40
S11	199	S9 and ((sens\$3 detect\$3) with (position\$3 align\$3))	US-PGPUB; USPAT	OR	ON	2004/08/08 17:40
S12	23	S9 and ((sens\$3 detect\$3) with (position\$3 align\$3) with compar\$4)	US-PGPUB; USPAT	OR	ON	2004/08/08 17:40
S13	1819	((118/719) or (414/939) or (156/345.31) or (156/345.32)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/08/08 17:28
514	31	(((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS:) and 156/345.24:ccls.	US-PGPUB; USPAT	OR	ON	2003/12/12 18:38
S15	322	(((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((position\$3 align\$4) with (detect\$3 sens\$3 monitor\$3 sens\$3))	US-PGPUB; USPAT	OR	ON	2003/12/12 18:39
S16	1757	(118/715-733:ccls: 156/345.\$:ccls: 414/935-941.ccls:) and ((position\$3 align\$4) with (detect\$3 sens\$3 monitor\$3 sens\$3))	US-PGPUB; USPAT	OR	ON	2003/12/12 18:39
S17	43	(118/715-733.ccls. 156/345.\$.ccls. 414/935-941.ccls.) and ((position\$3 align\$4) with (detect\$3 sens\$3 monitor\$3 sens\$3) with (inlet entry entrance))	US-PGPUB; USPAT	OR	ON	2003/12/12 18:40
S18	3	(("5483138") or ("5917601") or ("6004047")).PN:	US-PGPUB; USPAT; USOCR	OR.	OFF	2003/12/18:18:25
S19	1	("5512320").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2003/12/18 18:42
S20	1827	((118/719) or:(414/939) or (156/345:31) or (156/345:32)).CCLS.	US-PGPUB; USPAT; USOCR	ÖR	OFF	2003/12/18 18:43
S21	331	(((118/719) or (414/939) or (156/345.31) or (156/345.32)). CCLS.) and ((position\$3 align\$3) with (sens\$3 detect\$3 monitor\$3 observ\$5))	US-PGPUB; USPAT	OR	ON	2003/12/18 19:36

S22 '	384	((156/345.13) or (156/345.15) or (156/345.24)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2003/12/18 18:50
S23	58	tamura-naoyuki.in.	US-PGPUB; USPAT	OR	ON	2005/04/16 20:08
S24	214	c23c016\$.ipc. and ((position\$3 align\$3) with (sens\$3 detect\$3 monitor\$3 observ\$5))	EPO; JPO; DERWENT	OR	ON	2003/12/18 19:36
S28	20	(US-20030023343-\$ or US-20030168173-\$ or US-20040074603-\$ or US-20040151574-\$).did: or (US-4507078-\$ or US-4618292-\$	US-PGPUB; USPAT	OR	ON	2004/11/10 17:39
		or. US-4643579-\$ or: US-4654106-\$ or: US-4819167-\$ or: US-4836733-\$ or: US-5452521-\$ or: US-5483138-\$ or: US-5512320-\$ or: US-5814196-\$ or: US-5917601-\$ or:				
		US-5980194-\$ or US-6166509-\$ or US-6368183-\$ or US-6370793-\$ or US-6553280-\$).did.				